

Message Text

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PAGE 01 STATE 086061
ORIGIN COME-00

INFO OCT-01 CIAE-00 DODE-00 EB-08 NSAE-00 USIA-06
TRSE-00 EUR-12 ERDA-05 ISO-00 ACDA-07 /039 R

DRAFTED BY COMMERCE/OEA - RGAREL:JAS
APPROVED BY EB/ITP/EWT - RPRACHT
RPE

-----161229Z 105920 /22
R 160238Z APR 77
FM SECSTATE WASHDC
TO USMISSION OECD PARIS

C O N F I D E N T I A L STATE 086061

EXCON

E.O. 11652: XGDS-1

TAGS: ESTC, COCOM, PL, US

SUBJECT: US POWER SEMICONDUCTOR MANUFACTURING FACILITY TO
POLAND - IL 1355

REF: A) OECD PARIS 10349, B) STATE 70267,
C) A-1474 (BEWT CASE NO. 222653)

1. USDEL REQUESTED TO MAKE FOLLOWING CHANGES IN THE
DRAFT DOCUMENT ATTACHED TO REF. C.

IN PARA. 1, DELETE LIST OF EQUIPMENT AND SUBSTITUTE THE
FOLLOWING:

1 LOT EQUIPMENT, TOOLING AND ACCESSORIES FOR THE PRODUCTION
OF POWER THYRISTORS AND TRANSISTORS. SEE ATTACHMENT 1.

IN PARA. 3, DELETE REFERENCES TO "D2201 RECTIFIER DIODE"
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AND TO "1.2 MILLION DIODES".

2. IN ADDITION, ISSUANCE OF THE US LICENSE WILL BE CONTIN-
GENT UPON CONDITIONS IN LD 3223. USDEL IS REQUESTED TO
EITHER CONVEY THIS INFORMATION TO THE COMMITTEE ORALLY OR
INCORPORATE IT IN THE COCOM DOCUMENT.

3. NEW ATTACHMENT 1 LISTING EQUIPMENT INVOLVED AND COPY
OF LD 3223 FORWARDED FROM COMMERCE APRIL 15. BROCHURES
FORWARDED APRIL 13.
CHRISTOPHER

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NNN

Message Attributes

Automatic Decaptioning: X
Capture Date: 01-Jan-1994 12:00:00 am
Channel Indicators: n/a
Current Classification: UNCLASSIFIED
Concepts: STRATEGIC TRADE CONTROLS, EXPORT LICENSES, SEMICONDUCTOR DEVICES
Control Number: n/a
Copy: SINGLE
Sent Date: 16-Apr-1977 12:00:00 am
Decaption Date: 01-Jan-1960 12:00:00 am
Decaption Note:
Disposition Action: RELEASED
Disposition Approved on Date:
Disposition Case Number: n/a
Disposition Comment: 25 YEAR REVIEW
Disposition Date: 22 May 2009
Disposition Event:
Disposition History: n/a
Disposition Reason:
Disposition Remarks:
Document Number: 1977STATE086061
Document Source: CORE
Document Unique ID: 00
Drafter: RGAREL:JAS
Enclosure: n/a
Executive Order: X1
Errors: N/A
Expiration:
Film Number: D770133-0222
Format: TEL
From: STATE
Handling Restrictions: n/a
Image Path:
ISecure: 1
Legacy Key: link1977/newtext/t19770449/aaaabqsh.tel
Line Count: 66
Litigation Code IDs:
Litigation Codes:
Litigation History:
Locator: TEXT ON-LINE, ON MICROFILM
Message ID: f8d5cba3-c288-dd11-92da-001cc4696bcc
Office: ORIGIN COME
Original Classification: CONFIDENTIAL
Original Handling Restrictions: n/a
Original Previous Classification: n/a
Original Previous Handling Restrictions: n/a
Page Count: 2
Previous Channel Indicators: n/a
Previous Classification: CONFIDENTIAL
Previous Handling Restrictions: n/a
Reference: 77 OECD PARIS 10349, 77 STATE 70267
Retention: 0
Review Action: RELEASED, APPROVED
Review Content Flags:
Review Date: 01-Mar-2005 12:00:00 am
Review Event:
Review Exemptions: n/a
Review Media Identifier:
Review Release Date: n/a
Review Release Event: n/a
Review Transfer Date:
Review Withdrawn Fields: n/a
SAS ID: 2782982
Secure: OPEN
Status: NATIVE
Subject: US POWER SEMICONDUCTOR MANUFACTURING FACILITY TO POLAND - IL 1355
TAGS: ESTC, PL, US, COCOM
To: OECD PARIS
Type: TE
vdkgvwkey: odb://SAS/SAS.dbo.SAS_Docs/f8d5cba3-c288-dd11-92da-001cc4696bcc
Review Markings:
Margaret P. Grafeld
Declassified/Released
US Department of State
EO Systematic Review
22 May 2009
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